PATENT 8030-1014

IAP20 Rec'd PCT/PTO 20 JUN 2006

In re application of

Tatsuo UCHIDA et al.

Conf.

Application No. NEW NATIONAL PHASE

Group

Filed June 20, 2006

Examiner

PROJECTION DISPLAY-USE SCREEN AND PROJECTION DISPLAY SYSTEM OPTICAL SYSTEM

INFORMATION DISCLOSURE STATEMENT (SUBMISSION CONCURRENT WITH THE FILING OF A NEW PATENT APPLICATION)

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

June 20, 2006

Sir:

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Pursuant to 37 C.F.R. §§ 1.97 and 1.98, and in fulfillment of the duty of disclosure under 37 C.F.R. § 1.56, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION I.

The patents, publications, or other information submitted for consideration by the Office are listed on PTO-1449, attached hereto.

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- Copies of the U.S. patents or publications are not submitted since the USPTO has waived their submission for applications filed after June 30, 2003. П
- Submitted herewith is a legible copy of (i) each foreign patent; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed.
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III.	CONC:	ISE EX ck at	RELEVANCE RELEVANCE RECUPEI/PIO 20 JUN 2006 least one box)
	a.		DOCUMENTS IN THE ENGLISH LANGUAGE
			The attached non U.S. patents, non U.S. patent application publications, foreign publications, or other information in the English language do not require a statement of relevancy.
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			An English language version of the search report or action that indicates the degree of relevance found by the foreign office is attached, thereby satisfying the requirement for a concise explanation. See MPEP 609(A)(3).
	d.		OTHER
			The following additional information is provided for the Examiner's consideration.
			FEES
conc ther	This urren efore	Inf tly , no :	Formation Disclosure Statement is being filed with the filing of a new patent application; fee is required.
is r	If T	he Ex ted to	aminer has any questions concerning this IDS, he/she contact the undersigned.
			Respectfully submitted,
			YOUNG & THOMPSON
			Benoît Castel
			Benoit Castel, Reg. No. 35,041 745 South 23 rd Street Arlington, VA 22202 Telephone (703) 521-2297 Telefax (703) 685-0573 (703) 979-4709
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Encl	osure	s:	
			<pre>Documents</pre>
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INFORMATION DISCLOSURE CITATION
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(Use several sheets if necessary)

Attomey	Docket	No.:
8030-	1014	

Applicant: Tatside (VEHIDA PETAL PTO 20 JUN 2006

Filing Date: June 20, 2006 Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
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Initial						Yes	No
	2003-530590	10/14/2003	JAPAN				
	2004-526183	8/26/2004	JAPAN				
	2003-508800	3/4/2003	JAPAN				
	2005-195740	7/21/2005	JAPAN				
	2004-302223	10/28/2004	JAPAN				· ·
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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